

## DESCRIPTION

RESIST COMPOSITION5        Cross-References to Related Applications

This application claims benefit under 35U.S.C. §119(e) to United States Provisional Application Serial No. 60/489,493, filed July 24, 2003.

Technical Field

10        The present invention relates to a resist composition used for the production of printed boards and, more particularly, to a water-based solution or dispersion type resist composition, and a method of producing a resist-coated substrate using the same.

15        Background Art

A printed circuit board has hitherto been produced by forming a resist coating film on an insulating substrate comprising a conductive metal layer such as copper foil (which may contain metal other than copper, hereinafter referred merely to a "copper-clad substrate"), exposing to light through a photomask having a prescribed pattern, developing with water or alkali water, etching the conductive metal layer at the portion where no resist is remained with an etching solution, and removing the resist to form a prescribed wiring pattern.

25        Examples of the method of forming a resist layer on a copper-clad substrate include a dry film method and a liquid resist coating method. In the liquid resist coating method, a dip coating method is known, in addition to a method of coating a liquid resist on a copper-clad substrate by means of roll coating or screen printing. This method comprises dipping a copper-clad substrate in a large amount of a resist composition solution (commonly in the form of a solution), pulling up the copper-clad substrate, and drying it thereby to vaporize the solvent, thus forming a resist coating film on the copper-clad substrate.

A high volatile organic solvent has conventionally been used as a solvent in a liquid resist composition to be used in a dip coating method. Under the apprehension of an adverse influence on the human body and  
5 environment, a resist composition containing water as a solvent disclosed in Japanese Unexamined Patent Publication (Kokai) No. 53-97416 has recently been proposed.

When applying the resist composition containing  
10 water to the dip coating method, there arises a problem that copper ions eluted from a copper plate accumulate in a resist solution thereby to cause ion crosslinking. In the dip coating method, the operation of dipping a copper-clad substrate in large excess of a resist  
15 solution for a given time and pulling up the copper-clad substrate is performed, and metal ions such as copper ions are eluted during the dipping operation. During the dipping operation, considerable portion of the resist solution in contact with the substrate is remained in the  
20 resist solution. In case of the production on a large scale, this resist solution is repeatedly used, and thus metal ions such as copper ions gradually accumulate in the resist solution. As a result, crosslinking of resist components is caused by metal ions such as copper ions,  
25 resulting in an increase in viscosity of the resist solution and, in worse case, precipitates and aggregates are formed. This arise problems, for example, change in thickness of the coating film, formation of foreign matters on the coated substrate and the like. The former  
30 can be solved by adjusting the coating conditions, while the latter is hardly avoided.

Severe problem such as accumulation of metal ions into the resist solution arises in the dip coating method, and may also arise in other resist layer forming  
35 methods such as liquid resist coating method.

In order to suppress crosslinking due to metal ions such as copper ions eluted from the copper-clad

substrate, the addition of a chelating agent in a water-based electrodeposition coating composition is proposed in Japanese Examined Patent Publication (Kokoku) No. 6-44150. However, the compound disclosed in the patent  
5 document has a problem that it exerts insufficient effect and deteriorates sensitivity to ultraviolet light.

An object of the present invention is to improve storage stability of a solution or dispersion type resist composition containing water as a solvent during a  
10 repeating dip coating operation while maintaining sensitivity of the resist composition.

Under these circumstances, the present inventors have intensively studied and found that the object described above can be achieved by using a specific  
15 compound and a specific organic solvent in combination in a water-containing resist composition for dip coating, and thus the present invention have been completed. The present invention is directed to [1] to [8] described below.

20       Summary of the Invention

[1] A resist composition comprising (A) a resin component, (B) a photopolymerization initiator, (C) water and (D) an organic solvent, wherein the organic solvent (D) contains:

25       (D-1) at least one organic solvent selected from the group consisting of an  $\alpha$ -hydroxycarboxylate ester, a  $\beta$ -alkoxycarboxylate ester, a 1,3-diol compound and a 1,3-diol compound derivative, and

30       (D-2) an organic solvent having a hydroxyl group other than (D-1).

[2] The resist composition according to [1], wherein (D-1) is an  $\alpha$ -hydroxycarboxylate ester.

[3] The resist composition according to [2], wherein the  $\alpha$ -hydroxycarboxylate ester is a lactate ester.

35 [4] A method of producing a resist-coated substrate, which comprises dipping an insulating substrate

comprising a conductive metal in the resist composition according to any one of [1] to [3].

[5] A method of producing a print circuit board, which comprises using the resist composition according to any one of [1] to [3].

[6] A resist composition for dip coating comprising (A) a resin component, (B) a photopolymerization initiator, (C) water and (D) an organic solvent, wherein the organic solvent (D) contains:

(D-1) at least one organic solvent selected from the group consisting of an  $\alpha$ -hydroxycarboxylate ester, a  $\beta$ -alkoxycarboxylate ester, a 1,3-diol compound and a 1,3-diol compound derivative.

[7] A method of producing a resist-coated substrate, which comprises dipping an insulating substrate comprising a conductive metal in the resist composition according to [6].

[8] A method of producing a print circuit board, which comprises using the resist composition according to [6].

## Detailed Description of the Invention

The present invention will now be described in detail.

### (A) Resin component

The resin component (A) used in the resist composition of the present invention is soluble in a developer and is slightly soluble in an etching solution, and is preferably a component containing a resin having a carboxyl group or an anhydride group thereof in the molecule. Examples of the resin having a carboxyl group or an anhydride group thereof in the molecule include an acrylic resin, which is a copolymer containing (meth)acrylic acid and (meth)acrylate as a monomer, a copolymer of (meth)acrylic acid and ethylene, and a copolymer of maleic anhydride and ethylene or styrene, and the acrylic resin is particularly preferable in view of adhesion and tack.

The (meth)acrylic acid means methacrylic acid and/or

acrylic acid.

The resin component (A) is preferably a photopolymerizable resin which can cause photopolymerization by means of irradiation with ultraviolet light, X-ray or electron beam in the presence or absence of a photopolymerization initiator, and examples thereof include those having a plurality of polymerizable groups such as ethylenically unsaturated bonds in the molecule.

As the photopolymerizable resin, publicly known photopolymerizable resins can be used alone or in combination and, for example, it can be selected from the following groups (1) to (5).

(1) a reaction product of an unsaturated hydroxyl compound, and a resin having at least one functional group selected from the group consisting of a carboxyl group, a carboxylic anhydride group, an isocyanate group and an epoxy group;

(2) a reaction product of an unsaturated epoxy compound, and a resin having at least one functional group selected from the group consisting of a carboxyl group, a carboxylic anhydride group, an isocyanate group, an amino group and a hydroxyl group;

(3) a reaction product of an unsaturated carboxylic acid or an unsaturated carboxylic anhydride, and a resin having at least one functional group selected from the group consisting of a hydroxyl group, an amino group, an isocyanate group and an epoxy group;

(4) a reaction product of an unsaturated amino compound, and a resin having at least one functional group selected from the group consisting of a carboxyl group, a carboxylic anhydride group, a formyl group, a keto group, an isocyanate group and an epoxy group; and

(5) a reaction product of an unsaturated isocyanate compound, and a resin having at least one functional group selected from the group consisting of a carboxyl group, a carboxylic anhydride group, an amino group, a

hydroxyl group and an epoxy group.

While the weight-average molecular weight and acid value (mgKOH/g) of these photopolymerizable resins are not specifically limited, the weight-average molecular weight is preferably within a range from 500 to 100,000, more preferably from 1,000 to 50,000, and most preferably from 2,000 to 20,000, and the acid value is preferably within a range from 20 to 350, more preferably from 50 to 250, and most preferably from 80 to 200.

The weight-average molecular weight is measured by gel permeation chromatography and the acid value is measured by the procedure defined in JIS K5601.

Specific examples of the unsaturated hydroxyl compound include 2-hydroxyethyl (meth)acrylate, 2-hydroxypropyl (meth)acrylate, polyethylene glycol mono(meth)acrylate (e.g. diethylene glycol monoacrylate), polyethylene glycol mono(meth)acrylate (e.g. triethylene glycol mono(meth)acrylate), 1,4-butanediol mono(meth)acrylate, ethylene glycol mono(meth)allyl ether, polyethylene glycol mono(meth)allyl ether (e.g. diethylene glycol mono(meth)allyl ether), N-methylolacrylamide, allyl alcohol, methallyl alcohol, hydroxystyrene, hydroxymethylstyrene, and allyl phenol.

Specific examples of the unsaturated epoxy compound include glycidyl (meth)acrylate, allyl glycidyl ether, and 3,4-epoxycyclohexylmethyl (meth)acrylate.

As the unsaturated carboxylic acid and anhydride thereof, for example, there can be used (meth)acrylic acid, crotonic acid, itaconic acid, maleic acid, fumaric acid, sorbic acid, tetrahydrophthalic acid, cinnamic acid, nadic acid, oleic acid, linoleic acid, linolenic acid, eleostearic acid, licanic acid, ricinoleic acid, arachidonic acid, and anhydrides thereof.

Examples of the unsaturated amino compound include allylamine, diallylamine, aminostyrene, aminomethylstyrene, acrylamide, and a reaction product of an unsaturated carboxylic acid or a derivative thereof

and polyamine such as ethylenediamine.

As the unsaturated isocyanate compound, for example, there can be used 2-isocyanate ethyl (meth)acrylate, allyl isocyanate, and a reaction product of an  
5 unsaturated hydroxyl compound and polyisocyanate such as tolylene diisocyanate or xylylene diisocyanate.

The resin having at least one functional group used in (1) to (5) is at least one homopolymer or copolymer selected from among the above-mentioned unsaturated  
10 carboxylic acid, unsaturated carboxylic anhydride, unsaturated isocyanate compound, unsaturated epoxy compound, unsaturated hydroxy compound and unsaturated amino compound.

Examples of the resin having a carboxyl group as a  
15 functional group include poly(meth)acrylic acid, a (meth)acrylic acid-methyl (meth)acrylate copolymer, a (meth)acrylic acid-styrene copolymer, a styrene-maleic anhydride copolymer, an ethylene-(meth)acrylic acid copolymer, terminal carboxylated polybutadiene, a  
20 terminal carboxylated butadiene-acrylonitrile copolymer, and an (anhydrous) polyhydric carboxylic acid adduct of a phenol resin.

Examples of the resin having a hydroxyl group include polyhydroxyethyl (meth)acrylate, a hydroxyethyl  
25 (meth)acrylate-styrene copolymer, a hydroxyethyl (meth)acrylate-methyl methacrylate copolymer, a novolak type phenol resin, polyvinyl alcohol, a partially saponified ethylene-vinyl acetate copolymer, polyglycerin, polyvinyl phenol, a carboxylic acid adduct  
30 of an epoxy resin, polyethylene glycol, polypropylene glycol, terminal hydroxylated (hydrogenated) polybutadiene, terminal hydroxylated (hydrogenated) petroleum resin, and a reaction product of polyhydric alcohol and polyhydric isocyanate.

35 Examples of the resin having an epoxy group include polyglycidyl (meth)acrylate, a glycidyl (meth)acrylate-styrene copolymer, a glycidyl (meth)acrylate-methyl

methacrylate copolymer, a reaction product of a novolak type phenol resin and epichlorohydrin, a reaction product of polyhydric phenol and epichlorohydrin, and a reaction product of polyhydric alcohol and epichlorohydrin.

5        Examples of the resin having an amino group include polyacrylamide, polyallylamine, saponified polyvinyl formamide, saponified polyvinylacetamide, polyaminostyrene, an aminostyrene-styrene copolymer, a reaction product of a carboxyl group-containing resin and  
10    polyvalent amine, an urea resin, and a melamine resin.

      Examples of the resin having an isocyanate group include poly-2-isocyanate ethyl (meth)acrylate, a 2-isocyanate ethyl (meth)acrylate-methyl (meth)acrylate copolymer, and a reaction product of a polyhydric  
15    isocyanate compound and a polyhydric hydroxyl compound.

      More specifically, preferable examples of (1) to (5) include:

(1-1) a reaction product of an unsaturated hydroxyl compound and a resin having a carboxylic anhydride group,  
20    for example, a reaction product of hydroxyethyl acrylate and a styrene-maleic anhydride copolymer, and those obtained by further reacting these reaction products with a base;

(1-2) a reaction product of an unsaturated hydroxyl  
25    compound and a resin having an isocyanate group;

(2-1) a reaction product of an unsaturated epoxy compound and a resin having a carboxyl group, for example, a reaction product of glycidyl acrylate and a methacrylic acid-methyl methacrylate copolymer, a reaction product of  
30    3,4-epoxy-cyclohexylmethyl acrylate and a methacrylic acid-methyl methacrylate copolymer, and those obtained by further reacting these reaction products with a base; and

(3-1) a reaction product of an unsaturated carboxylic acid or an unsaturated carboxylic anhydride and a resin  
35    having an epoxy group, for example, a reaction product of acrylic acid and polyglycidyl methacrylate, and a reaction product of acrylic acid and a glycidyl



methacrylate methyl methacrylate copolymer.

Among these reaction products, an acrylic resin composed of a copolymer of (meth)acrylic acid and an ester thereof, or a modified product thereof are particularly preferable, and specific examples thereof include a reaction product of glycidyl acrylate and a methacrylic acid-methyl methacrylate copolymer, a reaction product of 3,4-epoxy-cyclohexylmethyl acrylate and a methacrylic acid-methyl methacrylate copolymer, and those obtained by further reacting these reaction products with a base.

Examples of the photopolymerizable resin which can be used, in addition to (1) to (5), include:

- (6) a homopolymer or copolymer of a conjugated diene compound and a modified product thereof, for example, polybutadiene;
- (7) a polymerizable unsaturated resin obtained by adding an unsaturated dicarboxylic acid or an anhydride thereof to an unsaturated bond in a fatty acid chain in an esterified product of an epoxy resin and an unsaturated fatty acid;
- (8) a polymerizable unsaturated resin composed of an unsaturated fatty acid-modified high acid value alkyd resin; and
- (9) a mixture of a polymerizable unsaturated resin composed of maleinated oil and an ethylenically unsaturated compound having one or more polymerizable unsaturated bonds in a molecule.

#### (B) Photopolymerization initiator

As the photopolymerization initiator (B), for example, publicly known photopolymerization initiators can be used. Specific examples thereof include benzoin, benzoin methyl ether, benzoin ethyl ether, benzyl, diphenyl disulfide, tetramethylthiuram sulfide, diacetyl, eosin, thionine, Michlers' ketone, anthraquinone, chloroanthraquinone, methylantraquinone,  $\alpha$ -

hydroxyisobutylphenone, p-isopropyl- $\alpha$ -  
hydroxyisobutylphenone,  $\alpha,\alpha'$ -dichloro-4-  
phenoxyacetophenone, 1-hydroxy-1-cyclohexylacetophenone,  
2,2-dimethoxy-2-phenylacetophenone, methylbenzoyl  
5 formate, 2-methyl-1-[4-(methylthio)phenyl]-2-  
morpholinopropan-1-one, benzophenone, thioxanthone, 2-  
chlorothioxanthone, 2,4-diethylthioxanthone, 2-  
isopropylthioxanthone, 4-benzoyl-4'-methyldiphenyl  
sulfide, ethyl N,N-dimethylaminobenzoate, pentyl N,N-  
10 dimethylaminobenzoate, and triethanolamine. These  
photopolymerization initiators may be used alone, but are  
preferably used in combination.

The content of these photopolymerization initiators  
is within a range from 0.01 to 20% by weight, preferably  
15 from 0.1 to 15% by weight, and most preferably from 0.5  
to 10% by weight, based on the total weight (containing  
the solvent) of the resist composition of the present  
invention. When the content of the photopolymerization  
initiator (B) is less than 0.01% by weight,  
20 photopolymerization does not proceed sufficiently, and  
thus making it difficult to maintain performances as the  
resist. On the other hand, when the content exceeds 20%  
by weight, storage stability and properties of the  
coating film may deteriorate.

#### 25 (C) Water

The resist composition of the present invention  
contains water (C) as the solvent. Since the resist  
composition contains water (C), it is made possible to  
decrease the amount of a high volatile organic solvent  
30 and to increase a flash point of the resist composition  
and to improve safety during storage and transportation.  
The content of water (C) in the resist composition of the  
present invention is within a range from 5 to 80% by  
weight, preferably from 10 to 75% by weight, more  
35 preferably from 20 to 70% by weight, still more  
preferably from 25 to 65% by weight, and most preferably

from 30 to 60% by weight, based on the resist composition.

(D) Organic solvent

The organic solvent (D) of the present invention  
5 contains at least one organic solvent (D-1) selected from  
the group consisting of an  $\alpha$ -hydroxycarboxylate ester, a  
 $\beta$ -alkoxycarboxylate ester, a 1,3-diol compound and a 1,3-  
diol compound derivative, and a hydroxyl group-containing  
organic solvent (D-2) other than the organic solvent (D-  
10 1).

(D-1)

The organic solvent (D-1) is selected from the group  
consisting of an  $\alpha$ -hydroxycarboxylate ester, a  $\beta$ -  
alkoxycarboxylate ester, a 1,3-diol compound and a 1,3-  
15 diol compound derivative, and these compounds may be used  
alone or in combination. The content of the organic  
solvent (D-1) is within a range from 0.1 to 40% by  
weight, preferably 0.5 to 30% by weight, more preferably  
from 1.0 to 20% by weight, and most preferably from 1.0  
20 to 15% by weight, based on the resist composition of the  
present invention. When the content of the organic  
solvent (D-1) is less than 0.1% by weight, the effect of  
the present invention is not recognized. On the other  
hand, even if the organic solvent (D-1) is added in the  
25 amount of more than 40% by weight, an additional effect  
can not be expected.

Among the organic solvent (D-1) in the present  
invention, the  $\alpha$ -hydroxycarboxylate ester is not  
specifically limited and publicly known esters can be  
30 used. Specific examples of the  $\alpha$ -hydroxycarboxylate  
ester include glycolate esters such as methyl glycolate,  
ethyl glycolate, n-propyl glycolate, isopropyl glycolate,  
n-butyl glycolate, isobutyl glycolate, n-pentyl  
glycolate, n-hexyl glycolate, and cyclohexyl glycolate;  
35 lactate esters such as methyl lactate, ethyl lactate, n-

propyl lactate, isopropyl lactate, n-butyl lactate, isobutyl lactate, amyl lactate, isoamyl lactate, n-hexyl lactate, cyclohexyl lactate, and benzyl lactate;

$\alpha$ -hydroxybutyrate esters such as methyl  $\alpha$ -

5 hydroxybutyrate, ethyl  $\alpha$ -hydroxybutyrate, n-propyl  $\alpha$ -hydroxybutyrate, isopropyl  $\alpha$ -hydroxybutyrate, n-butyl  $\alpha$ -hydroxybutyrate, isobutyl  $\alpha$ -hydroxybutyrate, n-pentyl  $\alpha$ -hydroxybutyrate, n-hexyl  $\alpha$ -hydroxybutyrate, and cyclohexyl  $\alpha$ -hydroxybutyrate; and

10  $\alpha$ -hydroxyvalerate esters such as methyl  $\alpha$ -hydroxyvalerate, ethyl  $\alpha$ -hydroxyvalerate, n-propyl  $\alpha$ -hydroxyvalerate, isopropyl  $\alpha$ -hydroxyvalerate, n-butyl  $\alpha$ -hydroxyvalerate, isobutyl  $\alpha$ -hydroxyvalerate, amyl  $\alpha$ -hydroxyvalerate, n-hexyl  $\alpha$ -hydroxyvalerate, and  
15 cyclohexyl  $\alpha$ -hydroxyvalerate.

Among the organic solvent (D-1) in the present invention, the  $\beta$ -alkoxycarboxylate ester is not specifically limited and publicly known esters can be used. Specific examples of the  $\beta$ -alkoxycarboxylate ester  
20 include methyl 3-methoxy-propionate, ethyl 3-methoxy-propionate, methyl 3-methoxy-butyrate, ethyl 3-methoxy-butyrate, methyl 3-methyl-3-methoxy-butyrate, ethyl 3-methyl-3-methoxy-butyrate, methyl 2-methoxy-cyclohexane-carboxylate, and those wherein a methoxy group is  
25 replaced by the other alkoxy group such as ethoxy group.

Among the organic solvent (D-1) in the present invention, the 1,3-diol compound is not specifically limited and publicly known compounds having a 1,3-diol structure can be used. Also it may have the other  
30 functional group other than the diol structure, for example, hydroxyl group. Specific examples of the 1,3-diol compound include 1,3-propanediol, 1,3-butanediol, 2-methyl-1,3-propanediol, 2,2-dimethyl-1,3-propanediol, 2-

methyl-1,3-butanediol, 3-methyl-1,3-butanediol, 1,3-pentanediol, 2,4-pentanediol, 1,3-hexanediol, 2,4-hexanediol, trimethylolpropane, and pentaerythritol.

Among the organic solvent (D-1) in the present invention, the 1,3-diol compound derivative is a compound having such a structure that at least one hydroxyl group among two hydroxyl groups of a 1,3-diol structure is etherified or esterified, and publicly known compounds can be used without any limitation. Specific examples of the 1,3-diol compound derivative include 3-methoxy-1-propanol, 2-methyl-3-methoxy-1-propanol, 2,2-dimethyl-3-methoxy-1-propanol, 3-methoxy-1-butanol, 3-methoxy-3-methyl-1-butanol, and those wherein a methoxy group is replaced by an ethoxy group or the other alkoxy group; 3-acetoxy-1-propanol, 2-methyl-3-acetoxy-1-propanol, 2,2-dimethyl-3-acetoxy-1-propanol, 3-acetoxy-1-butanol, 3-acetoxy-3-methyl-1-butanol, and those wherein an acetoxy group is replaced by the other acyloxy group; and 3-methoxy-1-propyl acetate, 2-methyl-3-methoxy-1-propyl acetate, 2,2-dimethyl-3-methoxy-1-propyl acetate, 3-methoxy-1-butyl acetate, 3-methoxy-3-methyl-1-butyl acetate, those wherein a methoxy group is replaced by an ethoxy group or the other alkoxy group, and those wherein an acetoxy group is replaced by the other acyloxy group.

In order to increase the flash point of the resist composition of the present invention and to improve safety during storage and transportation, the flash point of the organic solvent (D-1) is commonly 40°C or higher, preferably within a range from 45 to 120°C, and more preferably from 50 to 110°C.

The organic solvent (D-2) of the present invention, namely a hydroxyl group-containing organic solvent other than the organic solvent (D-1), is a compound having one or more hydroxyl groups in the molecule and publicly known organic solvents can be used without any limitation. These organic solvents can be used alone or in combination. The content of the organic solvent (D-2)

is within a range from 1.0 to 40% by weight, preferably from 3.0 to 30% by weight, more preferably from 5.0 to 20% by weight, and most preferably from 7.0 to 15% by weight, based on the resist composition of the present invention. The content is preferably within the above range because a remarkable effect of the present invention is exerted even if the content of the organic solvent (D-1) is low. When the content of the organic solvent (D-2) is less than 1.0% by weight, the dispersion state of the resist composition may be unstable in case of low content of the organic solvent (D-1). On the other hand, even if the content exceeds 40% by weight, an additional effect can not be expected and the amount of the organic solvent increases, and thus merits of the addition of water may be impaired.

(D-2)

Specific examples of the organic solvent (D-2) include methanol, ethanol, 1-propanol, isopropanol, 1-butanol, 1-pentanol, ethylene glycol, propylene glycol, glycerin, 1,2-propanediol, diethylene glycol, triethylene glycol, tetraethylene glycol, ethylene glycol monomethyl ether, ethylene glycol monoethyl ether, ethylene glycol monobutyl ether, diethylene glycol monomethyl ether, diethylene glycol monoethyl ether, diethylene glycol monobutyl ether, triethylene glycol monomethyl ether, triethylene glycol monoethyl ether, triethylene glycol monobutyl ether, ethylene glycol monoacetate, diethylene glycol monoacetate, triethylene glycol monoacetate, propylene glycol monomethyl ether, propylene glycol monoethyl ether, propylene glycol monobutyl ether, dipropylene glycol monomethyl ether, dipropylene glycol monoethyl ether, dipropylene glycol monobutyl ether, dipropylene glycol monoacetate, and dipropylene glycol monoacetate.

To the resist composition of the present invention, other publicly known organic solvents can also be added,

if necessary, and examples thereof include ketones such as acetone, methyl ethyl ketone, and cyclohexanone; aromatic hydrocarbons such as toluene, xylene, ethylbenzene, and tetramethylbenzene; glycol ethers (e.g. 5 ethylene glycol monomethyl ether acetate, ethylene glycol monoethyl ether acetate, ethylene glycol monobutyl ether acetate, propylene glycol monomethyl ether acetate, propylene glycol monoethyl ether acetate, ethylene glycol dimethyl ether, ethylene glycol diethyl ether, ethylene 10 glycol dibutyl ether, diethylene glycol dimethyl ether, diethylene glycol diethyl ether, and diethylene glycol dibutyl ether), acetate esters (e.g. methyl acetate, ethyl acetate, and butyl acetate) and aliphatic hydrocarbons (e.g. octane, decane, and cyclohexane); and 15 petroleum solvents such as petroleum ether, petroleum naphtha, hydrogenated petroleum naphtha, and solvent naphtha.

(E) Polymerizable monomer

The resist composition of the present invention 20 preferably contains a polymerizable monomer (E), in addition to the above components (A) to (D). The polymerizable monomer (E) is not specifically limited as far as it is a compound which can cause polymerization in the presence of the photopolymerization initiator (B), 25 and publicly known polymerizable monomers can be used alone or in combination.

Examples of the polymerizable monomer (E) include the above-mentioned unsaturated hydroxyl compound, unsaturated epoxy compound, unsaturated carboxylic acid 30 or unsaturated carboxylic anhydride, unsaturated amino compound and unsaturated isocyanate compound, and styrene, vinyltoluene, divinylbenzene, alkyl (meth)acrylate such as methyl methacrylate, allyl ester, (meth)acrylate ester of polyhydric alcohol, and allyl 35 ether of polyhydric alcohol.

Examples of the (meth)acrylate of polyhydric alcohol include ethylene glycol di(meth)acrylate, diethylene

glycol di(meth)acrylate, triethylene glycol di(meth)acrylate, polyethylene glycol di(meth)acrylate, trimethylolpropane tri(meth)acrylate, ethoxylated trimethylolpropane tri(meth)acrylate, glycerin tri(meth)acrylate, pentaerythritoltetra (meth)acrylate, and ethoxylated pentaerythritoltetra (meth)acrylate. Examples of the allyl ether of polyhydric alcohol include ethylene glycol diallyl ether, diethylene glycol diallyl ether, diallyl ether, polyethylene glycol diallyl ether, trimethylolpropane triallyl ether, glycerin triallyl ether, and pentaerythritol tetraallyl ether.

(F) Thixotropic agent

The resist composition of the present invention can also contain a thixotropic agent (F). The thixotropic agent is a compound which can impart thixotropic properties to the resist composition, and publicly known thixotropic agents can be used alone or in combination. The content of the thixotropic agent is commonly within a range from 0.01 to 10.0% by weight, preferably from 0.1 to 5.0% by weight, and more preferably from 0.2 to 2.0% by weight, based on the resist composition. When the content is less than 0.01% by weight, the addition effect is not recognized. On the other hand, when the content exceeds 10% by weight, properties of the coating film may deteriorate because of poor dispersion.

The thixotropic agent is not specifically limited and publicly known thixotropic agents can be used. Examples thereof include inorganic compounds such as calcium stearate, zinc stearate, aluminum stearate, aluminum oxide, zinc oxide, magnesium oxide, glass, diatomaceous earth, titanium oxide, zirconium oxide, silicon dioxide, talc, mica, feldspar, kaolinite (kaolin clay), pyrophyllite (agalmatolite clay), sericite, bentonite, smectites/vermiculites (e.g. montmorillonite, beidellite, nontronite, and saponite), organic bentonite, and organic smectite; and ground organic compounds such as fatty acid amide wax, polyethylene oxide, acrylic



resin, amine salt of polymeric polyester, salt of linear polyaminoamide and polymeric polyester, amide solution of polycarboxylic acid, alkyl sulfonate, alkylallyl sulfonate, colloidal ester, polyester resin, phenol resin, melamine resin, epoxy resin, urethane resin, and polyimide resin. These thixotropic agents can be used alone or in combination.

Examples of commercially available inorganic thixotropic agent include Crown Clay, Burgess Clay #60, Burgess Clay KF, and OptiWhite (manufactured by Shiraishi Calcium Kaisha LTD.); Kaolin JP-100, NN Kaolin Clay, ST Kaolin Clay, and Hardsil (manufactured by Tsuchiya Kaolin Ind., Ltd.); ASP-072, Satintonplus, Translink 37, and Hydrousdelami NCD (manufactured by Angel Hard Corporation); SY Kaolin, OS Clay, HA Clay, and MC Hard Clay (manufactured by Maruo Calcium CO., LTD.); Rucentite SWN, Rucentite SAN, Rucentite STN, Rucentite SEN, and Rucentite SPN (manufactured by Corp Chemical); Sumecton (manufactured by Kunimine Industries Co., Ltd.); Bengel, Bengel FW, Esben, Esben 74, Organite, and Organite T (manufactured by Hojun Co.); Hodaka Jirushi, Orben, 250M, Bentone 34, and Bentone 38 (manufactured by Wilbur-Ellis Company); and Laponite, Laponite RD, and Laponite RDS (manufactured by Nippon Silica Industrial Co., Ltd.).

Examples of commercially available organic thixotropic agent include Disparon #6900-20X, Disparon #4200, Disparon KS-873N, and Disparon #1850 (manufactured by Kusumoto Chemicals); BYK-405 and BYK-410 (manufactured by BYC Chemie Japan Co.); Primal RW-12W (manufactured by Rohm&Haas Co.); and A-S-AT-20S, A-S-AT-350F, A-S-AD-10A, and A-S-AD-160 (manufactured by Itoh Oil chemicals Co., Ltd.). These compounds may be dispersed in the solvent.

Among these thixotropic agents, a silicate compound represented by  $xM(II)_2O \cdot ySiO_2$  (also including those corresponding to  $M(III)O$  or  $M(III)_2O_3$  wherein oxidation number is 2 or 3, x and y each represent a positive integer) is preferable and a swelling layer clay mineral

such as hectorite, bentonite, smectite or vermiculite is more preferable.

Among these thixotropic agents, an amine-modified silicate mineral (organic smectite: obtained by replacing  
5 an interlayer cation of sodium by an organic amine compound) can be preferably used and preferred examples thereof include those obtained by replacing a sodium ion of sodium/magnesium silicate (hectorite) by an ammonium ion. Examples of the ammonium ion include  
10 monoalkyltrimethylammonium ion having a C6-18 alkyl chain, dialkyldimethylammonium ion, trialkylmethylammonium ion, dipolyoxyethylene coconut oil alkylmethylammonium ion whose oxyethylene chain has 4 to 18 carbon atoms, bis(2-hydroxyethyl) coconut oil  
15 alkylmethylammonium ion, and polyoxypropylene methyldiethylammonium ion whose oxopropylene chain has 4 to 25 carbon atoms. These ammonium ions can be used alone or in combination. Examples of commercially available product thereof include Rucentite SAN,  
20 Rucentite STN, Rucentite SEN and Rucentite SPN (manufactured by Corp Chemical).

In the photosensitive composition of the present invention, polymerization inhibitors can also be used in combination. As the polymerization inhibitor,  
25 conventionally known inhibitors can be used and examples thereof include phenols (e.g. 3,5-ditert-butyl-4-hydroxytoluene), hydroquinones (e.g. hydroquinone, hydroquinonemonomethyl ether) and catechols (e.g. catechol, tert-butylcatechol, and pyrogallol).

30 In order to improve characteristics such as hardness, publicly known inorganic fillers such as barium sulfate, barium titanate, silicon oxide powder, amorphous silica, magnesium carbonate, calcium carbonate, aluminum oxide, aluminum hydroxide, glass fibers and carbon fibers  
35 can be optionally added to the photosensitive composition of the present invention.

Furthermore, there can be optionally added publicly

known coloring agents such as acid blue, phthalocyanine blue, phthalocyanine green, iodine green, disazo yellow, crystal violet, titanium oxide, carbon black, and naphthalene black; silicone, fluorine and polyméric  
5 defoaming agents and/or leveling agents; and tackifiers such as imidazole, thiazole, triazole and silane coupling agents.

In order to adjust surface tension, surfactants can be added to the resist composition of the present  
10 invention. The surfactant is not specifically limited and publicly known surfactants can be used. Examples thereof include anionic surfactants (e.g. sodium dodecylbenzene sulfonate, sodium laurate, and ammonium salt of polyoxyethylene alkyl ether sulfate), nonionic  
15 surfactants (e.g. polyoxyethylene alkyl ether, polyoxyethylene alkyl ester, polyoxyethylene sorbitan fatty acid ester, polyoxyethylene alkyl phenyl ether, polyoxyethylene alkylamine, and polyoxyethylene alkylamide) and acetylene glycol surfactants. In the  
20 present invention, these surfactants can be used alone or in combination.

The viscosity at 25°C of the resist composition of the present invention is preferably within a range from 5 to 500 mPa·s, more preferably from 10 to 300 mPa·s, still  
25 more preferably from 15 to 200 mPa·s, and most preferably from 20 to 150 mPa·s. When the viscosity is low, thixotropic properties are hardly imparted. On the other hand, when the viscosity is too high, it becomes difficult to adjust the thickness of the coating film  
30 during the dip coating. The viscosity is measured by using a commercially available B-type rotary viscometer.

In order to improve safety during storage and transportation, the flash point of the resist composition of the present invention is commonly 40°C or higher,  
35 preferably 55°C or higher, more preferably 60°C or higher, and most preferably 70°C or higher.

The resist composition of the present invention can

be produced by mixing the components described above by an arbitrary method, for example, a method of adding the respective components in a container equipped with a stirring blade while stirring. The respective components  
5 may be simultaneously added in a container in which the components are mixed, or may be successively added. The respective components may be added at a time, or may be added by plural portions. The temperature upon mixing is not specifically limited and is commonly within a range  
10 from 5 to 50°C, and preferably from 10 to 40°C. The mixing operation may be conducted at a given temperature, or may be conducted while varying the temperature.

The resist composition of the present invention can be applied to an arbitrary coating method and is  
15 particularly useful for a dip coating method. According to the resist composition of the present invention, it is made possible to suppress a problem of ion crosslinking due to metal ions including copper ions eluted from a copper plate while maintaining sensitivity.

20 The dip coating method is a publicly known method and a coated substrate is produced by charging a resist composition in a container, dipping an insulating substrate comprising a conductive metal layer such as copper-clad laminate therein, and pulling up at an  
25 arbitrary rate. In this case, the temperature of the resist composition in the container can be set to an arbitrary temperature and is preferably within a range from 10 to 50°C.

An apparatus used is not specifically limited and a  
30 publicly known apparatus can be used, and the apparatus is preferably an apparatus capable of varying a climbing rate during pulling-up so as to form a uniform film. Examples of commercially available dip coating apparatus include full-automatic dip coater AD-7200, semi-automatic  
35 dip coater SD-6200, and five coater SZC-720 (manufactured by SATUMA Communication Industry Co., Ltd.).

A printed circuit board having a prescribed wiring

pattern is commonly produced from a copper-clad substrate obtained by the dip coating method through the processes of drying, exposure, development, etching and removal of a resist film and optional other processes.

5        EXAMPLES

Example 1

1) Preparation of resist composition

While vigorously stirring of a uniform mixture of the respective components (A) to (F) described below,  
10    41.8 parts by weight of water (C) was added dropwise to the mixture over 15 minutes, followed by stirring for 15 hours. To the resulting solution, 3.0 parts by weight of ethyl lactate (D-1) and 0.3 parts by weight of an aqueous  
15    10 wt% polyvinyl alcohol solution were added, followed by stirring for one hour to prepare a resist composition.

(A) Resin component

13.8 Parts by weight of a 3,4-epoxy-cyclohexylmethyl acrylate-modified resin of a methacrylic acid-methyl methacrylate copolymer (manufactured by DAICEL CHEMICAL  
20    INDUSTRIES, LTD. under the trade name of Cyclomer ACA-200M, acid value: 100 mgKOH/g, weight-average molecular weight: 17,000)

(B) Photopolymerization initiator

2.4 Parts by weight of 2-methyl-1-(4-methylthiophenyl)-2-morpholinopropan-1-one  
25    (D-2)

14.0 Parts by weight of ethylene glycol monobutyl ether and 13.8 parts by weight of propylene glycol monomethyl ether

30    (E) Polymerizable monomer

1.4 Parts by weight of an acrylic acid adduct of bisphenol F diglycidyl ether (manufactured by NIPPON KAYAKU CO., LTD. under the trade name of PNA-142) and 5.2 parts by weight of polyethylene glycol diacrylate

35    (F) Thixotropic agent

0.7 Parts by weight of a polyoxypropylenemethyldiethylammonium cation-modified

product of hectorite

(Other components)

2.8 Parts by weight of N-methylmorpholine and 0.8  
parts by weight of propylene glycol monomethyl ether  
5 acetate

2) Evaluation of storage stability

After collecting 40 g of the resist composition thus  
produced in a sealable container, a copper-clad laminate  
measuring 5 cm × 10 cm (manufactured by Matsushita  
10 Electric Works. Ltd., comprising a copper foil on both  
sides) was put in the container and then stored at 40°C  
for 7 days. Then, it was confirmed whether or not  
precipitates were formed in the resist solution and a  
change in viscosity before and after storage was  
15 measured. The results were employed as criterion for  
evaluation of storage stability upon repeating dip  
coating.

3) Measurement of viscosity

The viscosity was measured at 25°C and 6 rpm by  
20 using a B-type viscometer (Model BL, No. 1 rotor)  
manufactured by TOKI SANGYO CO., LTD.

4) Dip coating of resist composition

The resist composition obtained in (1) was  
maintained at the temperature of 25°C and coated on a  
25 substrate using a dip coater manufactured by SATUMA  
Communication Industry Co., Ltd. (trade name: five coater  
FC-7500). The substrate was dried at 80°C for 15 minutes  
to obtain a coated substrate comprising a resist  
composition coating film having a thickness of about 8  
30 µm. After evaluation of storage stability (2), the  
resist composition was also dip-coated.

5) Measurement of sensitivity

The coated substrate (before and after evaluation of  
storage stability) obtained in (4) was exposed to  
35 ultraviolet light (ultra-high pressure mercury lamp,  
dominant wavelength: 365 nm, 80 mJ/cm<sup>2</sup>) through a

photomask (21-step density tablet, manufactured by Hitachi Chemical Co., Ltd.) and then developed by dipping in an aqueous 1% sodium carbonate solution at 30°C for 50 seconds.

5           The above results are shown in Table 1 below.

Table 1

	(D-1)		(D-2)		Viscosity (mPa·s)		Sensitivity (steps)		Precipitates
	Type	Parts by weight	Type	Parts by weight	Before storage	After storage	Before storage	After storage	
Example 1	Ethyl lactate	3	EGB/PGM	14.0/13.8	45	45	8	8	none
Example 2	Ethyl lactate	6	EGB/PGM	11.0/13.8	44	45	8	8	none
Example 3	Ethyl lactate	9	EGB/PGM	8.0/13.8	43	44	8	8	none
Example 4	Ethyl lactate	1	EGB/PGM	16.0/13.8	46	48	8	8	none
Example 5	Ethyl lactate	3	EGB	27.8	48	47	8	8	none
Example 6	Methyl lactate	3	EGB/PGM	14.0/13.8	43	44	8	8	none
Example 7	Butyl lactate	3	EGB/PGM	14.0/13.8	45	46	8	8	none
Example 8	Butyl lactate	6	EGB/PGM	11.0/13.8	45	45	8	8	none
Example 9	Butyl lactate	12	EGB/PGM	5/13.8	46	45	8	8	none
Example 10	1,3-propanediol	3	EGB/PGM	14.0/13.8	43	72	8	8	none
Example 11	2,2-dimethyl-1,3-propanediol	3	EGB/PGM	14.0/13.8	45	63	8	8	none
Example 12	1,3-butanediol	3	EGB/PGM	14.0/13.8	44	58	8	8	none
Example 13	3-methoxy-1-butanol	3	EGB/PGM	14.0/13.8	42	56	8	8	none
Example 14	3-methoxy-1-butanol	9	EGB/PGM	8.0/13.8	46	52	8	8	none
Example 15	3-methoxy-1-butanol	12	EGB/PGM	5/13.8	43	49	8	8	none

EGB: Ethylene glycol monobutyl ether

PGM: Propylene glycol monomethyl ether



Table 1 (continued)

	(D-1)		(D-2)		Viscosity (mPa·s)		Sensitivity (steps)		Precipitates
	Type	Parts by weight	Type	parts by weight	Before storage	After storage	Before storage	After storage	
Example 16	3-methyl-3-methoxy-1-butanol	3	EGB/PGM	14.0/13.8	47	52	8	8	none
Example 17	3-methyl-3-methoxybutyl acetate	3	EGB/PGM	14.0/13.8	44	53	8	8	none
Example 18	3-methoxybutyl acetate	3	EGB/PGM	14.0/13.8	46	61	8	8	none
Example 19	Methyl 3-methoxypropionate	3	EGB/PGM	14.0/13.8	43	67	8	8	none
Comparative Example 1	-	0	EGB/PGM	17.0/13.8	46	116	8	8	formed in large amount
Comparative Example 2	Acetylacetone	3	EGB/PGM	14.0/13.8	44	40	8	2	none
Comparative Example 3	Methyl acetoacetate	3	EGB/PGM	14.0/13.8	46	120	8	8	formed in large amount
Comparative Example 4	Methyl salicylate	3	EGB/PGM	14.0/13.8	43	113	8	8	formed in large amount
Example 20	Butyl lactate	30.8	-	0	49	89	8	8	none
Example 21	Butyl lactate	3	-	0	41	101	8	8	formed

EGB: Ethylene glycol monobutyl ether

PGM: Propylene glycol monomethyl ether

Examples 2 to 19

In the same manner as in Example 1, except that those described in Table 1 were used as (D-1) and (D-2) in the amounts described in Table 1, resist compositions were produced and evaluated. The results are shown in Table 1.

Comparative Example 1

In the same manner as in Example 1, except that ethyl lactate was not used and (D-2) EGB was used in the amount described in Table 1, a resist composition was produced and evaluated. The results are shown in Table 1.

Comparative Examples 2 to 4

In the same manner as in Example 1, except that acetylacetone, methyl acetoacetate and methyl salicylate described in Patent Document 2 (Japanese Examined Patent Publication (Kokoku) No. 6-44150) were used in place of (D-1) ethyl lactate, resist compositions were produced and evaluated. The results are shown in Table 1.

Example 20

In the same manner as in Example 1, except that all of (D-1) ethyl lactate, (D-2) ethylene glycol monobutyl ether and propylene glycol monomethyl ether were replaced by butyl lactate, a resist composition was produced and evaluated. The results are shown in Table 1.

Example 21

In the same manner as in Example 1, except that the total amount of (D-2) ethylene glycol monobutyl ether and propylene glycol monomethyl ether was replaced by water, a resist composition was produced and evaluated. The results are shown in Table 1.

As is apparent from the results shown in Table 1, the resist compositions of the present invention do not cause deterioration of sensitivity, increase of viscosity and formation of precipitates due to copper ions eluted from a copper plate as compared with the resist compositions of the prior art.

Effect of the Invention

The resist composition of the present invention can suppress a problem such as ion crosslinking due to copper ions eluted from a copper plate while maintaining  
5 sensitivity, especially in a dip coating method, and contributes to quality stabilization of printed circuit boards and improvement of productivity.